

03500.014179

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOICHI ANDO ET AL.

Application No.: 09/722,454

Filed: November 28, 2000

For: METHOD FOR MANUFACTURING
ELECTRON BEAM DEVICE,
METHOD FOR MANUFACTURING
IMAGE FORMING APPARATUS,
ELECTRON BEAM DEVICE AND
IMAGE FORMING APPARATUS
MANUFACTURED THOSE
MANUFACTURING METHODS,
METHOD AND APPARATUS FOR
MANUFACTURING ELECTRON
SOURCE AND APPARATUS FOR
MANUFACTURING IMAGE
FORMING APPARATUS

Examiner: M. Santiago

Group Art Unit: 2879

July 7, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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RESPONSE TO RESTRICTION AND ELECTION REQUIREMENTS

Sir:

This is in response to the Office Action dated June 5, 2003, imposing
restriction and election requirements in the above-identified application.

I hereby certify that this correspondence is being facsimile-transmitted to
the United States Patent and Trademark Office, Fax No. (703) 872-9318,
on

July 7, 2003
(Date of Transmission)

Jason M. Okun
(Name of Attorney for Applicants)

Signature

July 7, 2003
Date of Signature